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PATENT APPLICATION

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11/17/03
Date

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Registration No. 20,515

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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TECHNOLOGY CENTER 2800

Art Unit: 2878
Examiner: Shun K. Lee
Applicant: Ger van den Engh
Serial No.: 09/847,466
Filed: May 1, 2001
For: APPARATUS FOR DETERMINING RADIATION BEAM ALIGNMENT
Date: November 17, 2003

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Office communication dated September 16, 2003, relating to the above-identified application.


Enclosed is Exhibit A which was inadvertently omitted from the Response that was filed on June 19, 2003. It is submitted that the Response that was filed on June 19, 2003, and the

enclosed Declaration, provide a complete Response to the last Office Action.

Early reconsideration and allowance of this application are requested.

Respectfully submitted,

GER VAN DEN ENGH

By: 

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DJB/lam